Docket Number (Optional) Application Number 03226.111001;P INFORMATION DISCLOSURE CITATION Applicant(s) Wen-Chun ZHENG et al. (Use several sheets if necessary) Filing Date Group Art Unit U.S. PATENT DOCUMENTS FILING DATE EXAMINER CLASS SUBCLASS DATE NAME DOCUMENT NUMBER INITIAL IF APPROPRIATE FOREIGN PATENT DOCUMENTS Translation COUNTRY CLASS SUBCLASS DATE REF DOCUMENT NUMBER YES NO OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.) "Thermal Performance Challenges from Silicon to Systems" (pages 1-16) published in INTEL TECHNOLOGY JOURNAL Q3, 2000 Authors: Ram Viswanath, Technology and Manufacturing Group, Intel Corp.; Vijay Wakharkar, Technology and Manufacturing Group, Intel Corp.; Abhay Watwe, Technology and Manufacturing Group, Intel Corp.; and, Vassou Lebonheur, Technology and Manufacturing Group, Intel Corp. C.C. A1 DATE CONSIDERED **EXAMINER** 11/21/03

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